CT SERIES

Cluster Tools





The cluster tool (CT) series combines multiple PVD and CVD process capabilities into a single tool to provide maximum processing options. The ability to deposit films using a range of techniques in the same run enables fabrication of advanced multilayer stacks and device architectures. Each module can be configured individually to meet the technological requirements of the user, while also being extendable for future expansion.

CHAMBER CONFIGURATIONS



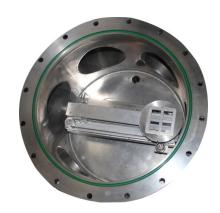


Manual Substrate Transfer





Automated Substrate Transfer



Telescopic transfer arm for indexing and substrate transfer



Showerhead electrode for PECVD



Magnetron sputtering



Electron beam evaporation

SPECIFICATIONS

CHAMBER SIZE Maximum chamber size: 450 mm (Ø) X 500 mm (H)

HV PUMPING OPTIONS

Turbo and Cryo pumps of suitable capacity

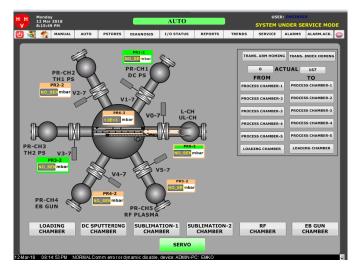
ROUGHING/BACKING OPTIONS Rotary/Dry

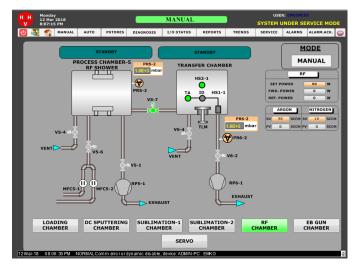
BASE PRESSURE Up to 10⁻⁷ mbar

SUBSTRATE SIZE Maximum upto 150 mm diameter

SUBSTRATE HOLDER Rotary, Watercooled, Heated, Bias and Z shift

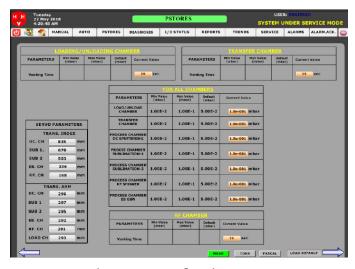
CONTROL OPTIONS





Auto Mode

Manual Mode



Instrument Settings

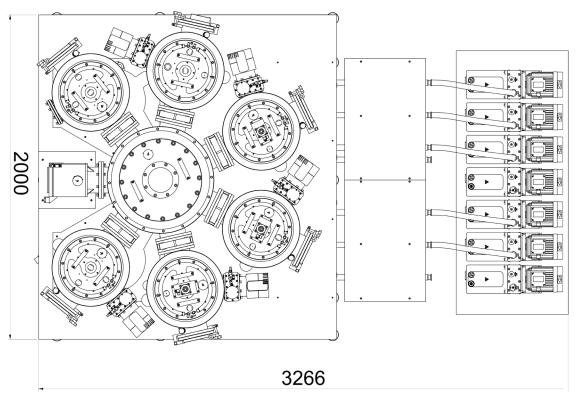
FEATURES

APPLICATIONS

- Modular design with up to 5 process chambers
- Manual or automated substrate transfer
- Sample heating, cooling, biasing and cleaning options
- PC/PLC controlled recipes for automated processes
- Advanced data logging and process tracking options
- Interlocks for safe operation

- Semiconductors
- Optical coatings
- Photovoltaics
- Metal coatings
- Organic Electronics
- Hybrid coatings

LAYOUT



All dimensions in mm Representative footprint. Actual dimensions will depend on system configuration



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